

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
)
Giacomo Nicolao MACCALLI,) Atty. Docket 47966.15.1
Olle KORDINA, Gianluca VALENTE,)
Danilo CRIPPA, and Franco PRETI)
)
Serial No. (TO BE ASSIGNED))
)
Based on)
Intl. Application No. PCT/IT2002/000773)
Intl. Filing Date: 10 December 2002)
)
Filed: (CONCURRENTLY HEREWITH))
)
For: SUSCEPTOR SYSTEM)

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Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. § 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicant respectfully requests that the Examiner initial each considered reference on the attached Form PTO-1449 and return a copy to Applicant.

This Information Disclosure Statement is being filed within three months of the U.S. filing date. No certification or fee is required.

By submitting these references, Applicant does not admit that the references are prior art to or material to this application, and reserves the right to establish that any reference is

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JC17 Rec'd PCT/PTO 10 JUN 2005

not prior art. Applicant does not represent that the references have been reviewed in detail;
there may be details in the references of which Applicant is unaware.

Respectfully submitted,


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#3130665\1

FORM PTO-1449 MODIFIED

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

APPLICATION NO.: (new) Based on Intl. App

No. PCT/IT2002/000773

FILING DATE: (new)

FIRST NAMED INVENTOR: Maccalli et al.

GROUP ART UNIT:

ATTORNEY DOCKET NO.: 47966.15.1

10/538416

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	Document No. Number-Kind Code ²	Date MM-DD- YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		2002/0090454A1	07/11/2002	Paisley et al.	
		2004/0020436A1	02/05/2004	Kaeppler et al.	(equiv to WO02/38838)
		4,667,076	05/19/1987	Amada	
		4,794,217	12/27/1988	Quan et al.	
		4,860,687	08/29/1989	Frijlink	
		5,221,356	06/22/1993	Hillier et al.	
		5,695,567	12/09/1997	Kordina et al.	
		5,788,777	08/04/1998	Burk, Jr.	
		5,792,257	08/11/1998	Kordina et al.	
		6,811,614	11/02/2004	Kappeler et al.	(equiv to WO02/38839)
		4,593,168	06/03/1986	Amada	
		5,155,062	10/13/1992	Coleman	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		WO02/38838	05/16/2002			<input type="checkbox"/>
		WO02/38839	05/16/2002			<input type="checkbox"/>
		GB 1 458 222	12/08/1976			<input type="checkbox"/>
		FR 2 650 841	02/15/1991		(Engl. abst. from corresp. WO91/02105)	<input type="checkbox"/>

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No. ¹		T ²
		Zhang, J., et al., "Growth Characteristics of SiC in a Hot-Wall CVD Reactor with Rotation", Journal of Crystal Growth 241 (2002) pp. 431-438	<input type="checkbox"/>
			<input type="checkbox"/>

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant. ¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.